



EFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/678,045 Confirmation No. : 6655  
First Named Inventor : Hiroshi SHINRIKI  
Filed : October 3, 2003  
TC/A.U. : 1762  
Examiner : Bret P. Chen

Docket No. : 010986.52822US  
Customer No. : 23911

Title : Method of and Apparatus for Processing Substrates

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REPLY**

Sir:

In response to the Office action of May 17, 2005, please amend the above-identified application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 6 of this paper.